



Construction the ITK IJC of ATLAS experiment for Phase 2 Upgrade

Abdenour Lounis

19/10/2020

Abdenour Lounis - French-Ukraine 2020 Workshop

1

Outline

- Context of the Tracker Upgrade project
- The French Cluster contribution
- Infrastructure and equipments for Module production
- Calendar and Milestone
- Conclusions

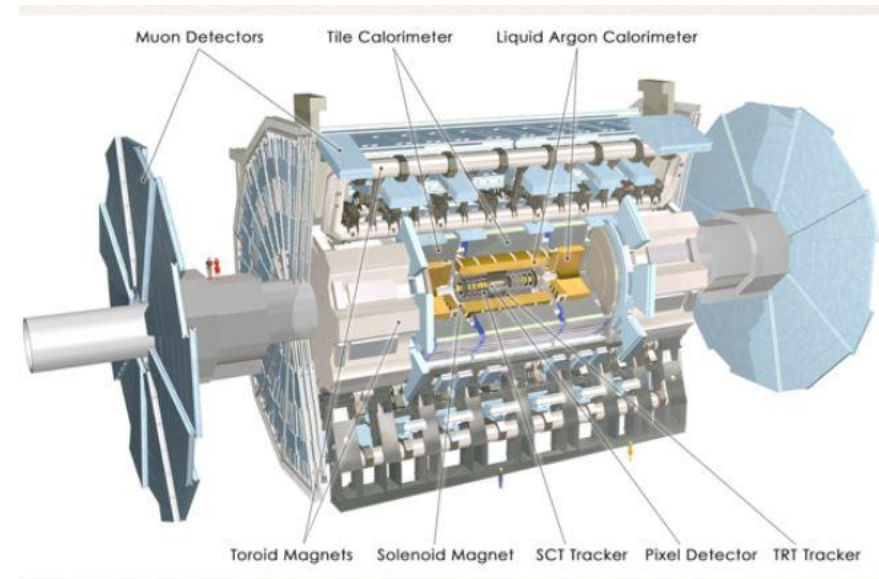


ATLAS Introduction

• Atlas Detector

- 3 tracking detectors with Large number of channels (Pixels, semi-conductor tracker and Transition Radiation Tracker with particle discrimination capability).
- 4 sampling calorimeter covering different regions (EM: Lead/liquid Argon; Tile Hadronic: iron/scintillators, Hadronic End caps : copper /liquid argon, Forward: copper/tungsten/liquid argon)
- Solenoid and toroid magnetics for charge and momentum measurements
- 4 muon detectors with complementary measuring and triggering capabilities
- Forward detectors

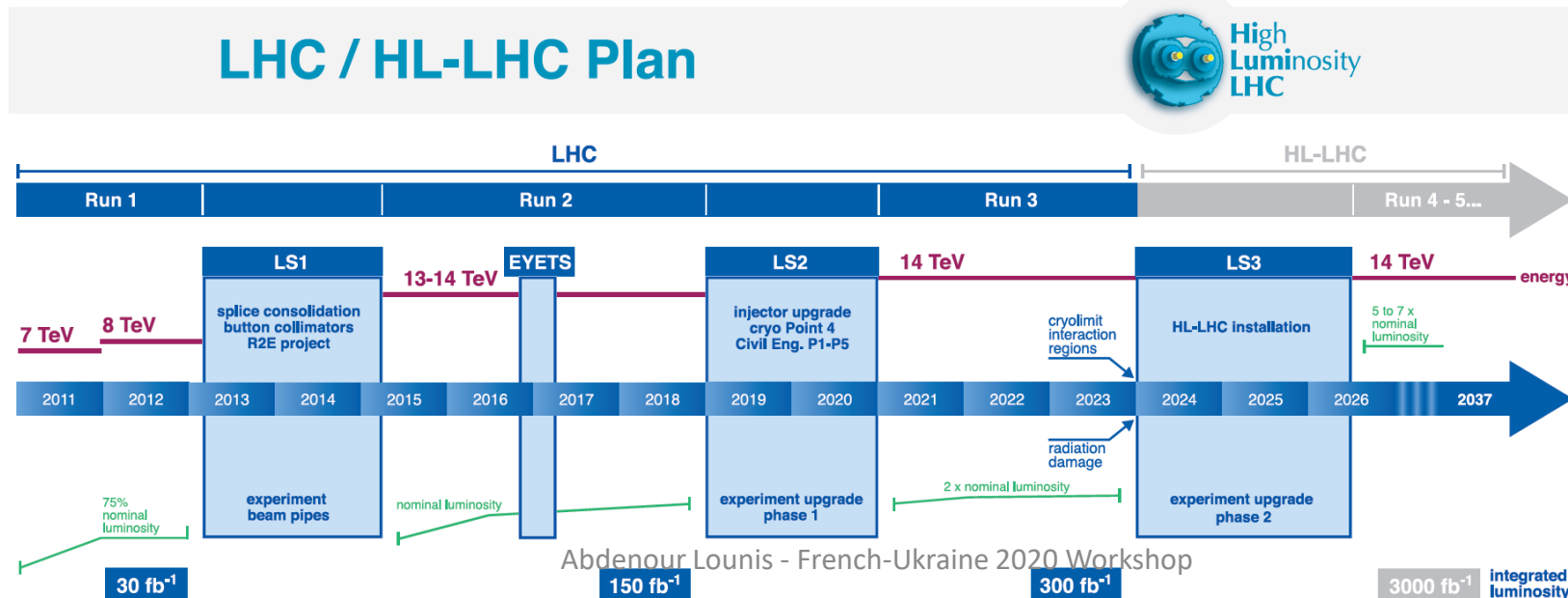
• Atlas view



Towards the upgrade



- The High Luminosity upgrade of the Large Hadron Collider (LHC) (HL-LHC) is currently expected to begin operations in the second half of 2026, with a nominal levelled instantaneous luminosity of $\mathcal{L} = 5 \times 10^{34} \text{cm}^{-2}\text{s}^{-1}$ corresponding to an average μ , of roughly 140 inelastic pp collisions each beam-crossing, and delivering an integrated luminosity of around 250fb^{-1} per year of operation.
- The ATLAS collaboration corresponding Phase-II up-grade of the detector, intended to take full advantage of the accelerator upgrade to achieve an ultimate luminosity of $\mathcal{L} = 7.5 \times 10^{34} \text{cm}^{-2}\text{s}^{-1}$ corresponding an average $\mu = 200$ inelastic pp collisions per beam-crossing. This programme aims to provide a total integrated luminosity of 3000fb^{-1} by 2035.



The detector upgrade to achieve physics objectives

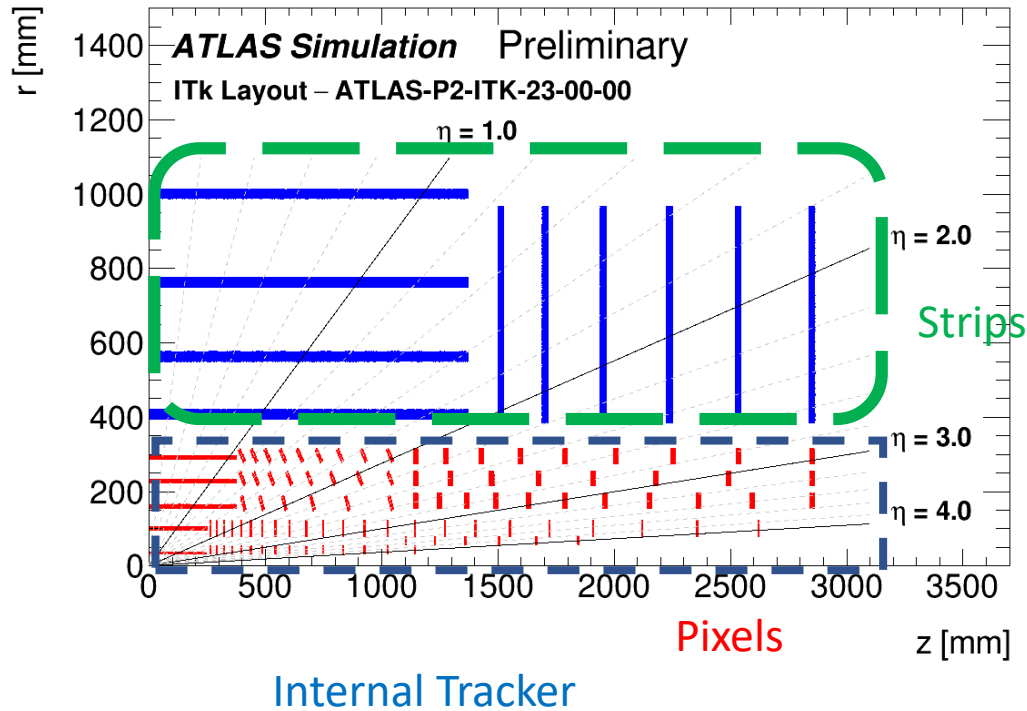
- LHC energy nominal limit (14 TeV).
- Precision measurements of the Higgs Boson properties at HL-LHC will be performed through all accessible production processes
- Complexity of the events is even larger : challenge, in particular for the inner detectors (radiation X10) and triggering.
- Some detectors won't survive the particle flu if no upgrade
- Experience with present detector helps to define main concerns in upgrade.

Detector system	Trigger-DAQ		Inner Tracker	Inner Tracker + Muon Spectrometer	Inner Tracker + Calorimeter		
Physics Process	Efficiency/Thresholds		b-tagging	μ^+ Identification/Resolution	Pile-up rejection	Jets	E_T^{miss}
	μ^+	e^+					
$H \rightarrow 4\mu$	✓			✓			
VBF $H \rightarrow ZZ^{(*)} \rightarrow \ell\ell\ell\ell$	✓	✓		✓	✓	✓	
VBF $H \rightarrow WW^{(*)} \rightarrow \ell\nu\ell\nu$	✓	✓	✓	✓	✓	✓	✓
SM VBS $ssWW$	✓	✓		✓	✓	✓	✓
SUSY, $\chi_1^\pm \chi_2^0 \rightarrow \ell b\bar{b} + X$	✓	✓	✓	✓	✓	✓	✓
BSM $HH \rightarrow b\bar{b}b\bar{b}$			✓			✓	

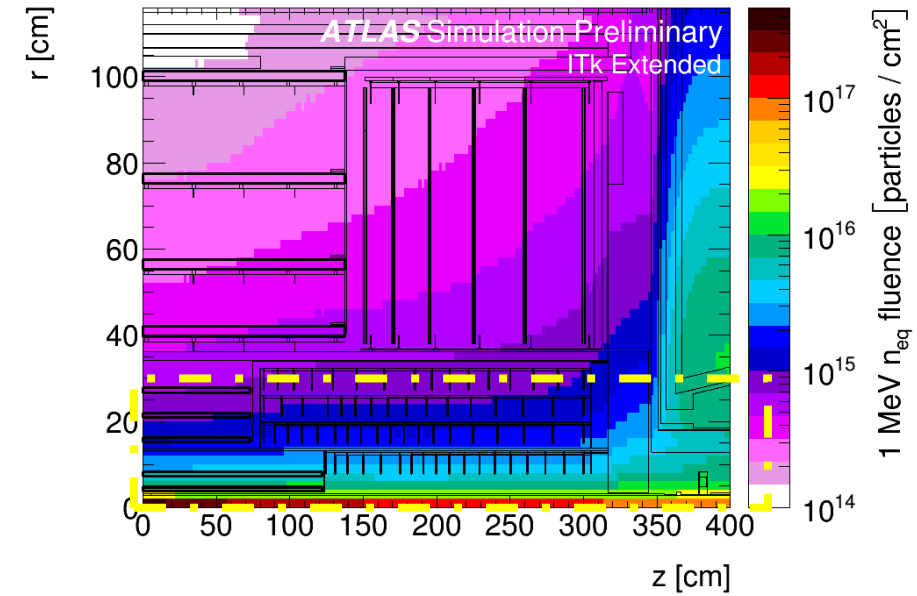
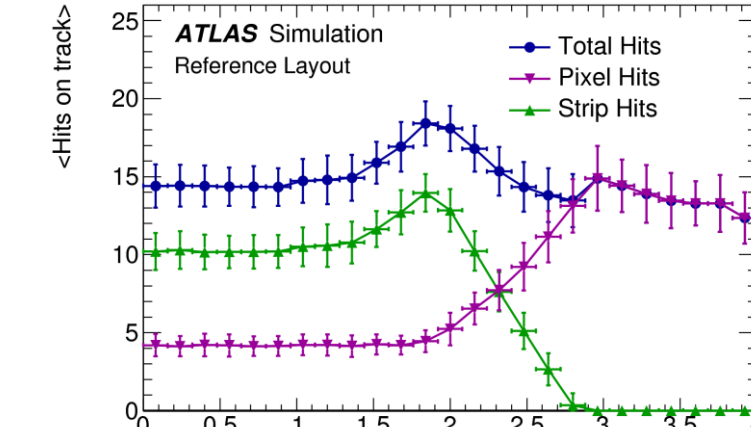
Overview of the physics analyses foreseen, and of the associated ATLAS sub-systems whose upgrades may impact the physics object performance

Focus on ITK

- ATLAS Inner Detector will be replaced by Inner Tracker (ITk)
- ITk consists of silicon strip (outside) and pixel sensors (inside)
 - One layer of 3D pixel sensors surrounded by layers of planar sensors
 - Planar thickness: 100 μm in layer 1 and 150 μm in layers 2-4
 - Planar pixel size: 50 \times 50 μm^2 ; (25 \times 100 μm^2 _ Layer 0)

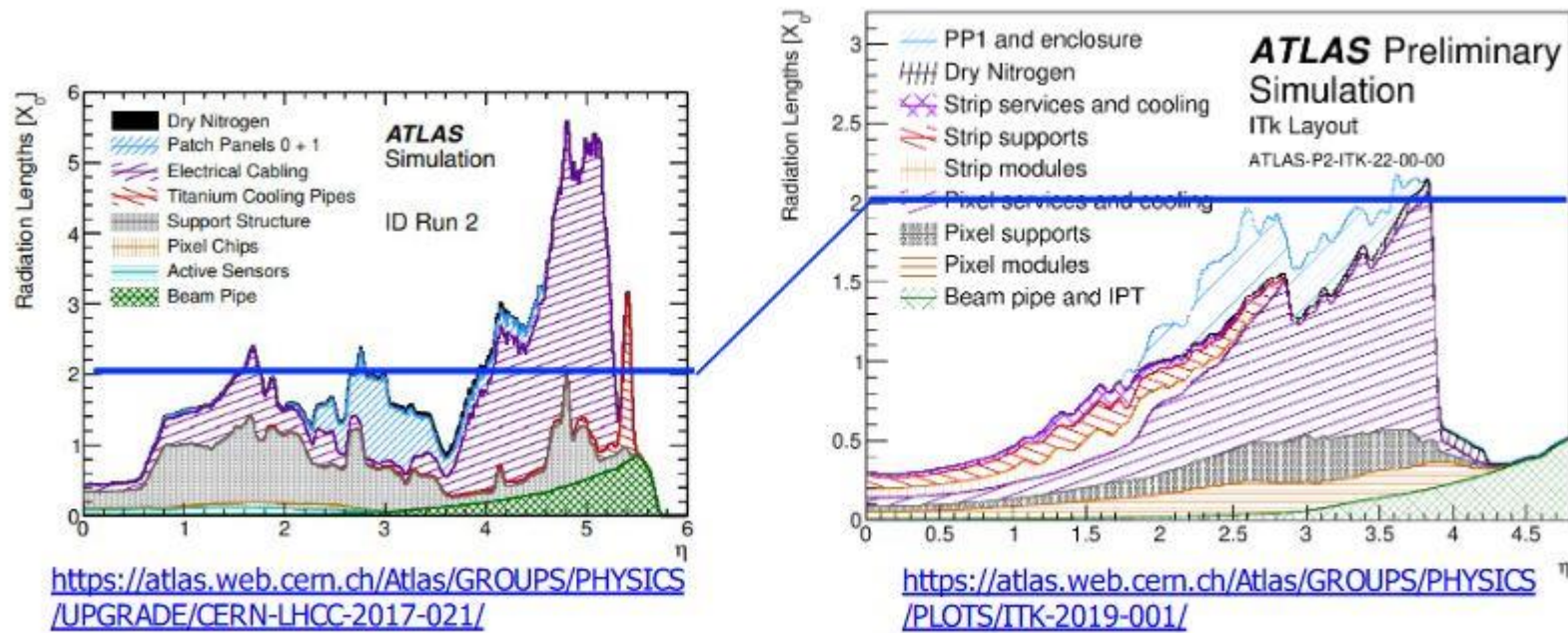


- Hits in the tracker ~ 15 Hits



Radiation fluences

Material Budget optimization

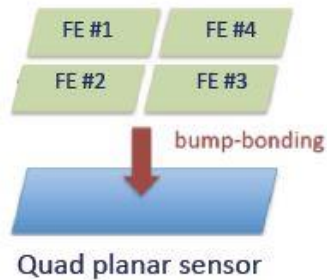


Pixel Modules details (Outer Barrel)

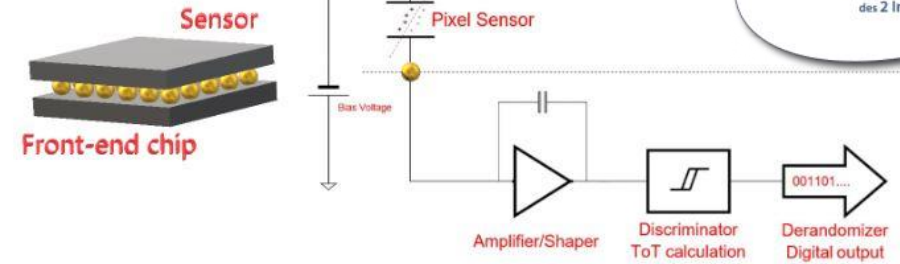
• Geometry & configuration

150 μm thick Si sensor for the outer barrel of approximate dimensions $4 \times 4 \text{ cm}^2$

- Planar pixel pitch: $50 \times 50 \mu\text{m}^2$
- ITk pixel readout chip is foreseen to be $20 \times 19.2 \text{ mm}^2$ relative to a matrix of 400 columns x 384 rows
- Planar sensors will be produced in a size compatible with 4-chip (quad)

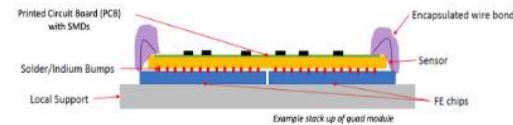
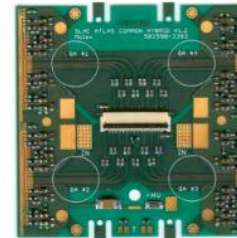


The working principle



Large Pixel system compared to current pixel in Run 2

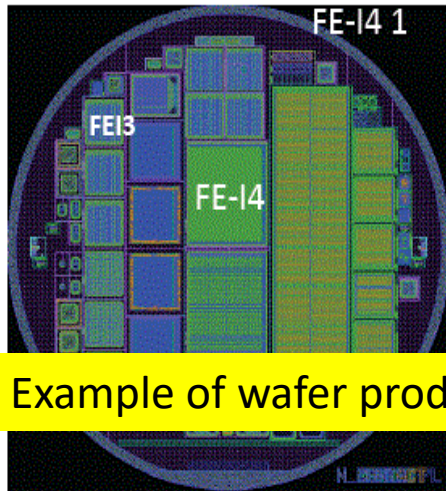
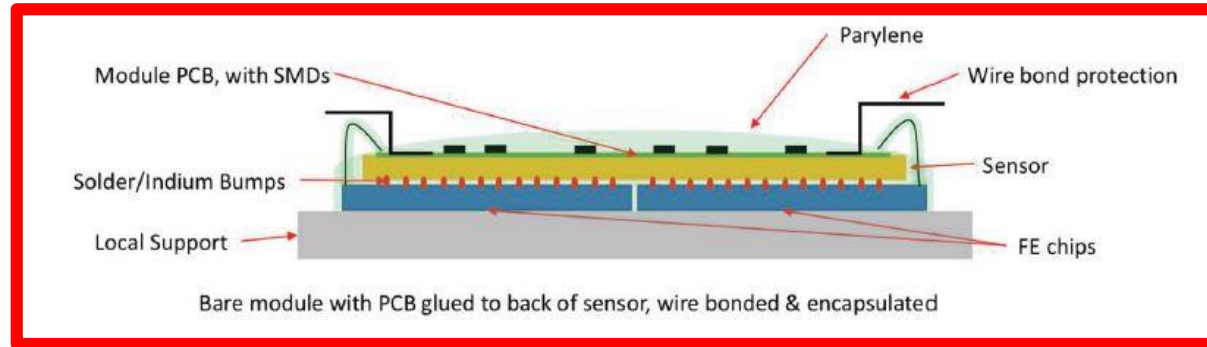
- ~60x channels,
- ~7x size,
- ~5x modules



Modules loaded on different structures according to the subsystem

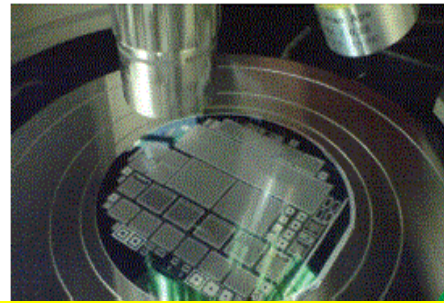
Components	Materia Budget X0
Front-end Chip, 150 μm thick	0.19
Sensor, 150 μm thick	0.17
Bumps	0.03
Module Flex	0.27
Flex adhesive	0.01
Total	0.67

Zoom on module

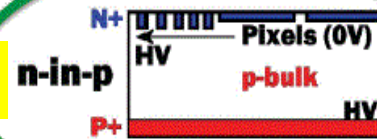
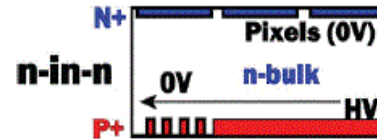


Example of wafer production

See: ATL-UPGRADE-PUB-2010-001; Nucl.Instrum.Meth. A730 (2013) 215

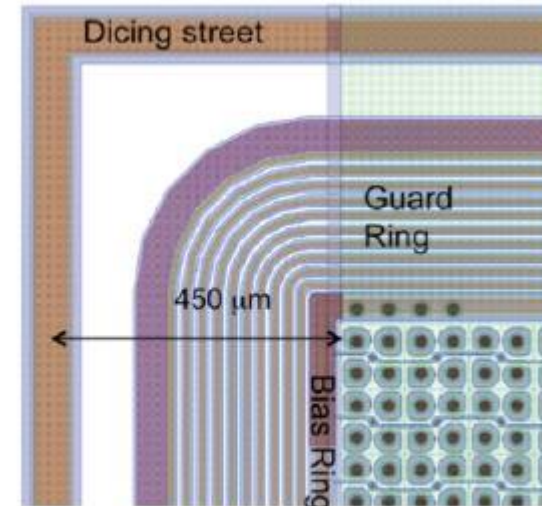


Present design



Future design

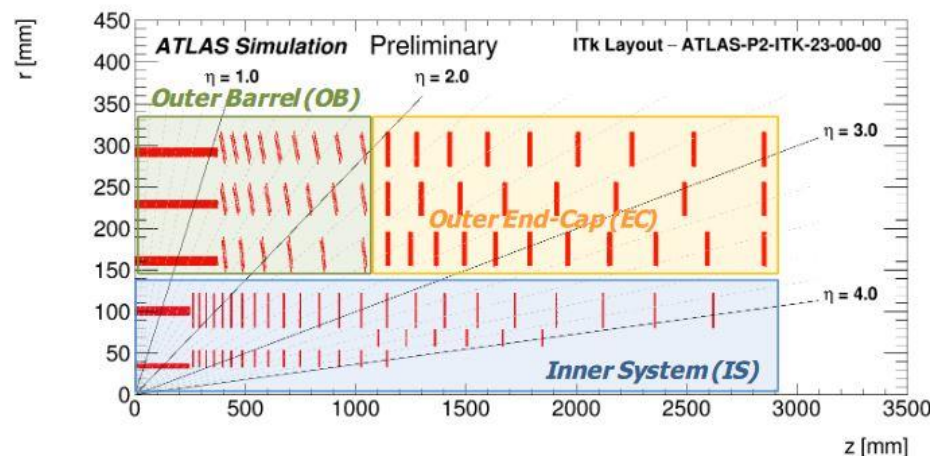
Cheaper and more rad-hard than n-in-n; ¹³



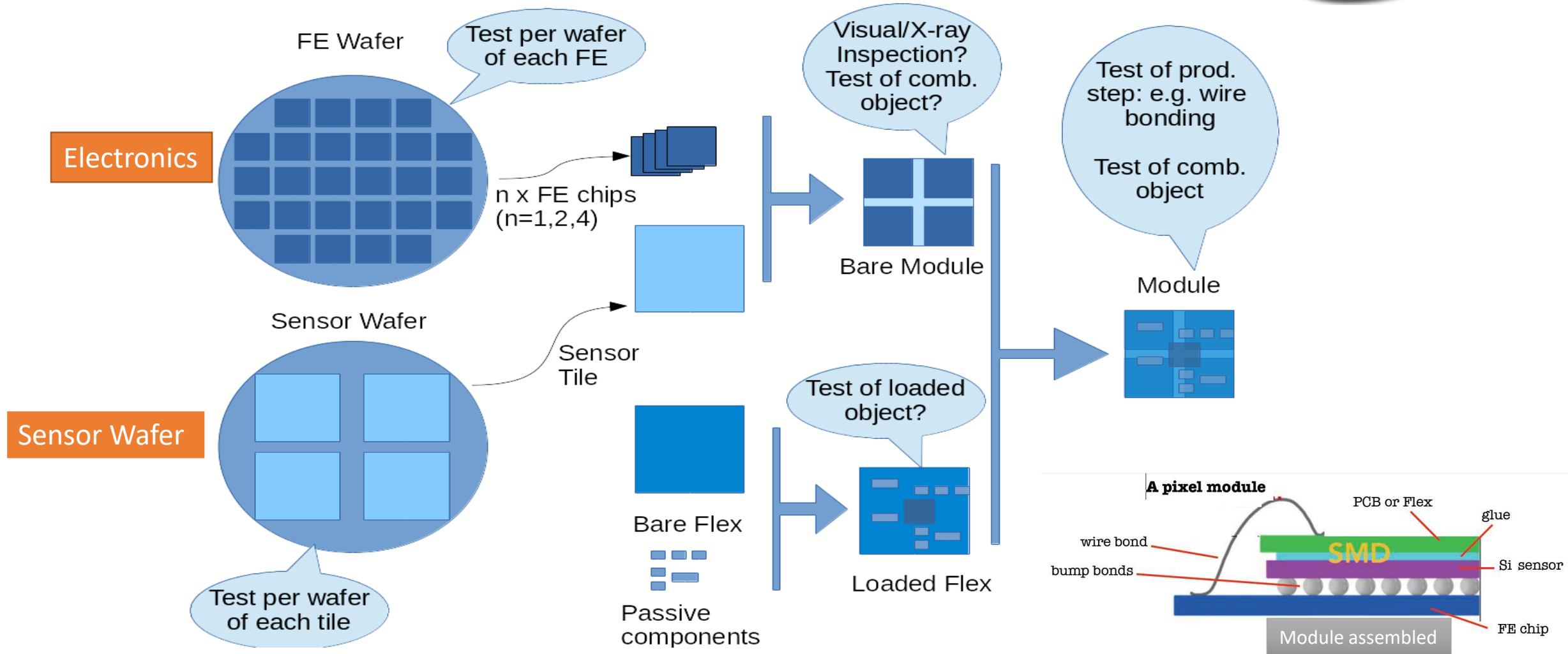
Example for a 150 μm thick sensor

The Cluster Ile de France

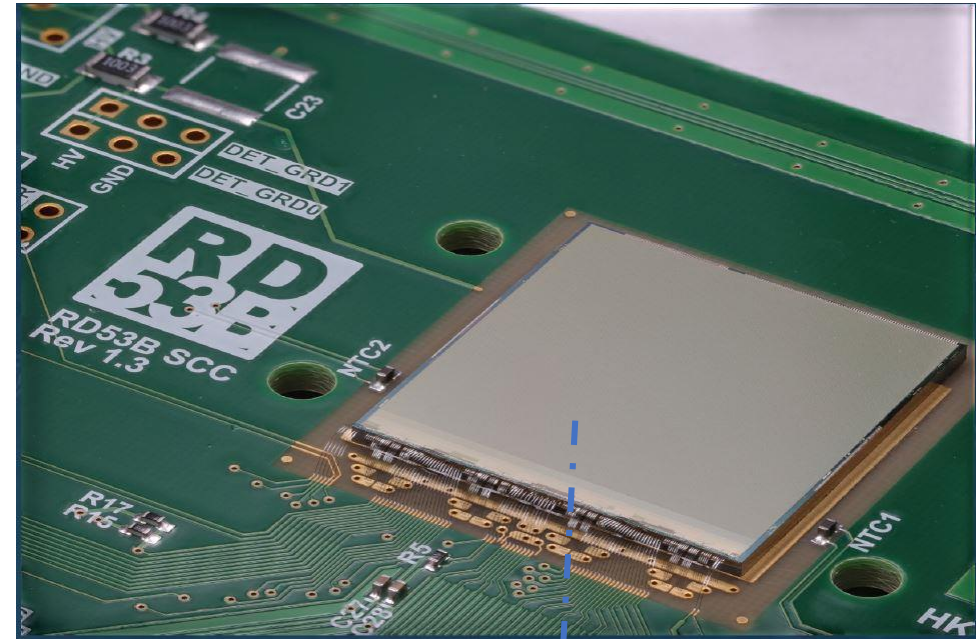
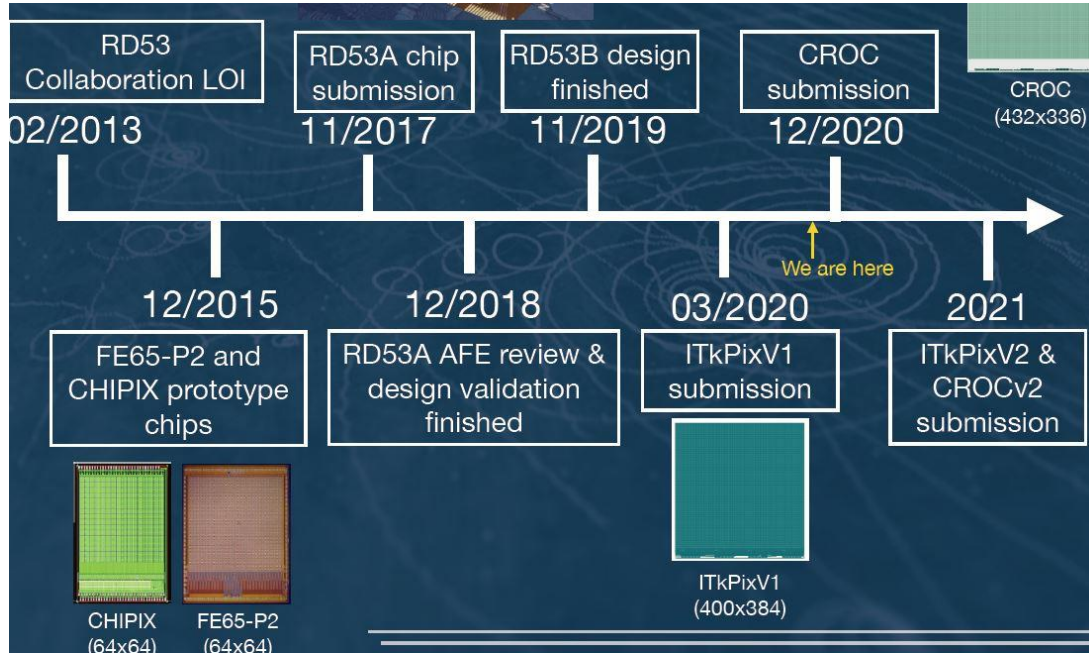
- Joined effort of three Laboratories
 - LPNHE (Université Pierre et Marie-Curie)
 - IJC Lab (Université Paris Saclay)
 - CEA-IRFU Saclay
- Overall commitment to contribute to 33% of the ITK outer barrel Pixel Construction



Overall strategy for Module Production

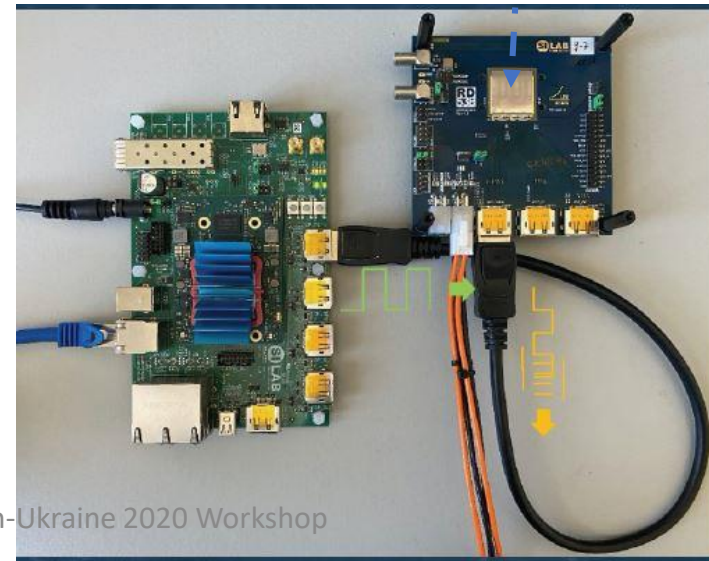


ATLAS Readout Chip developments (LPNHE & IJC are member of RD53 Collaboration)



ITKpixV1 properties

	RD53	Current Pixel
Chip Size	2x2 cm ²	2x2cm ²
Pixel Size	50x50 μm ²	50x250 μm ²
Pixel Hit Rate	3 GHz/cm ²	400 MHz/cm ²
Trigger rate	4/1 MHz	100 kHz
Trigger Latency	12.8 μs/51.2 μs	6.4 μs
Current consumption	<8 μA/pixel	20 μA/pixel
Radiation Tolerance	0.5 Grad	300 Mrad
Min. stable Threshold	600 e	1500 e



QC

- QC aims at identifying defects in the finished sensor
- Its goal is to identifying and discard faulty sensors
- It is a reactive process
- Tests are made as much as possible on the final product

QA

- QA aims at preventing defects on the production process
- Its goal is to assure that the fault does not happen
- It's a proactive process
- Tests can be made on other structures

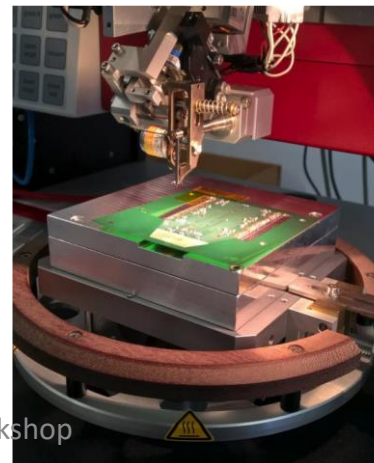
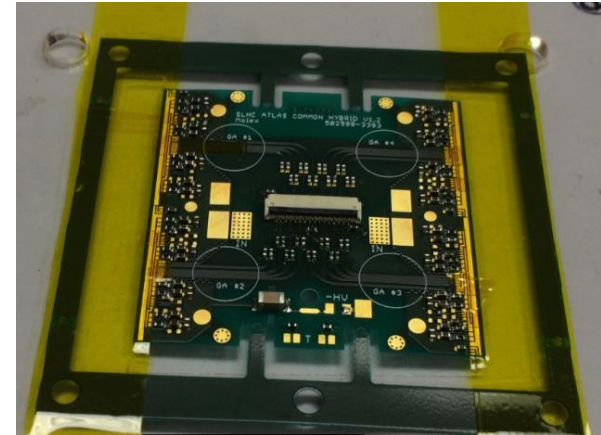
Working operation steps to follow



Planned Quality Control during production

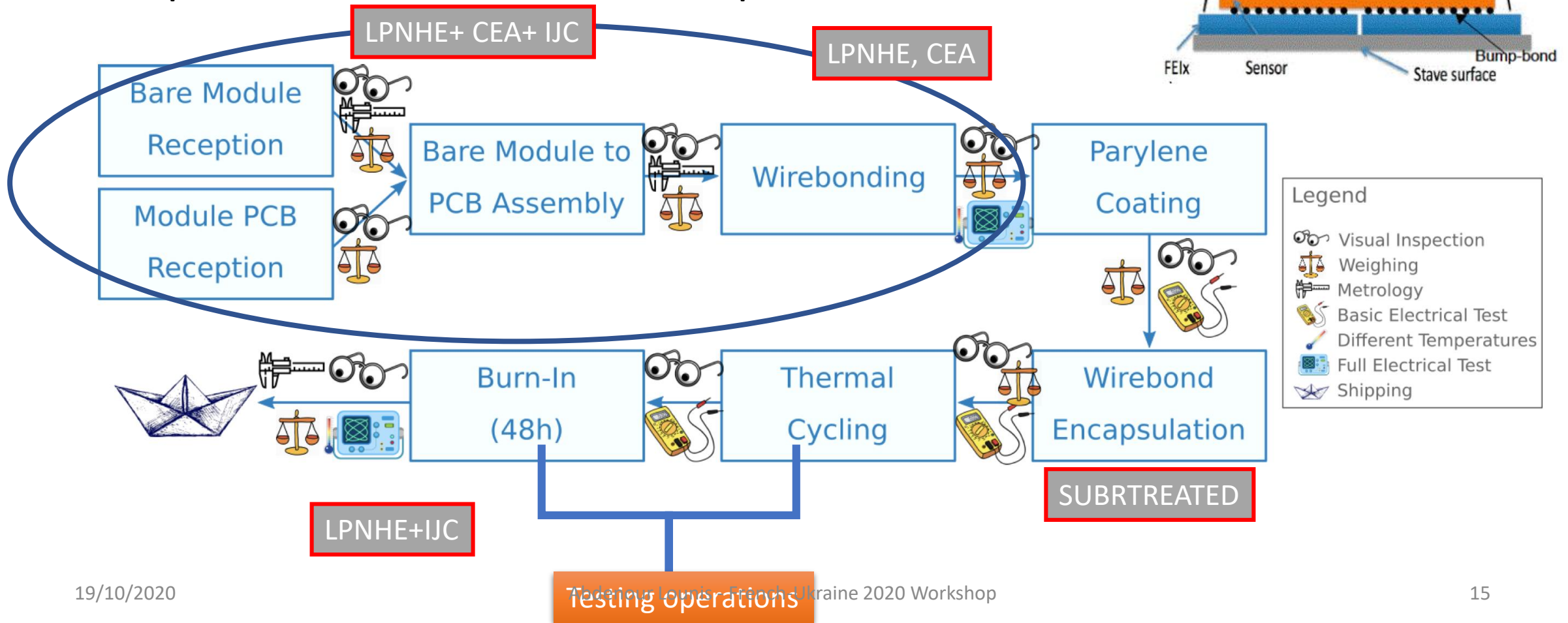
Tests are divided into Quality Control (QC) tests which are applied to all modules or their components and Quality Assurance (QA) tests, i.e. tests which are done on a subset of modules or their components.

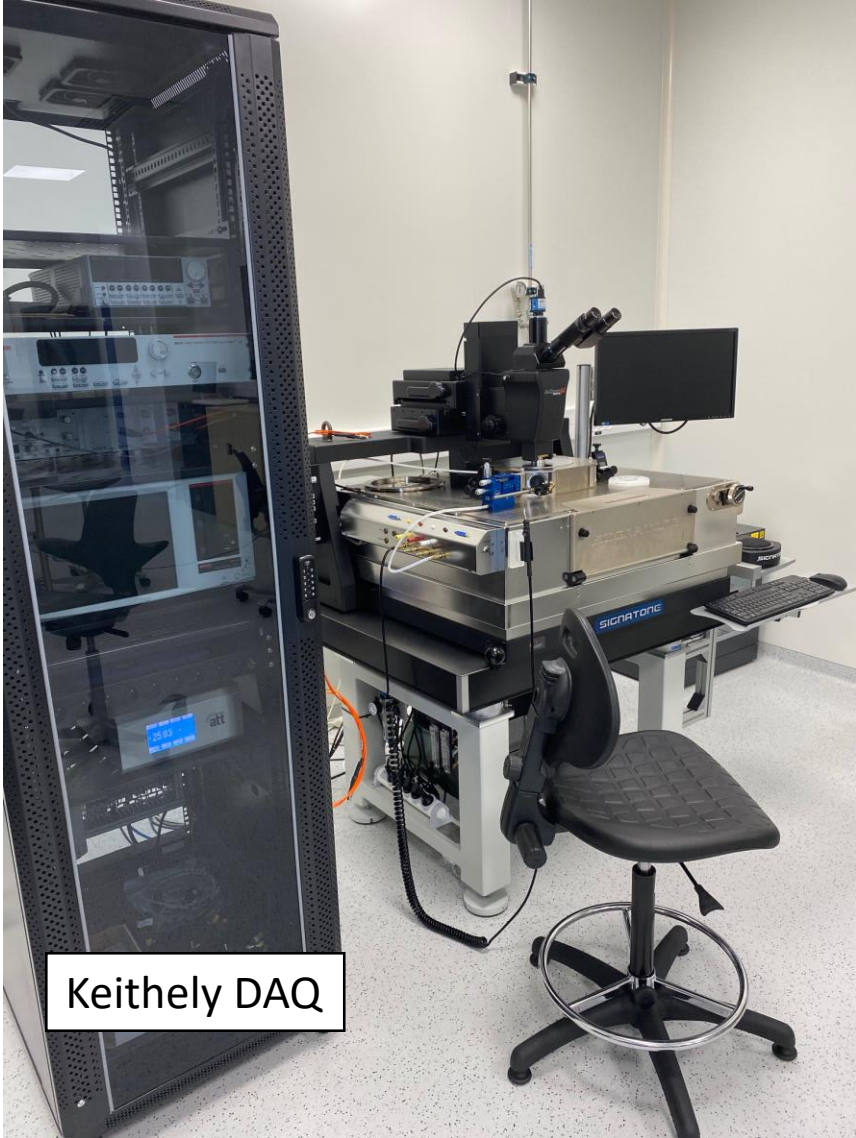
- Bare module reception tests (QC)
- Module flex reception tests (QC)
- ❖ Quality assurance tests to module flex (QA)
- Mass measurements and inspection of the fully assembled modules (QC)
- Wire bond pull testing (QC)
- Initial module tests (QC)
- Long term module tests (QC)
- ❖ Module tests beyond its operating range and destructive tests (QA)



Module Quality Control/Quality Assurance- Organization in French Cluster

Sequences for Module QA/QC operations

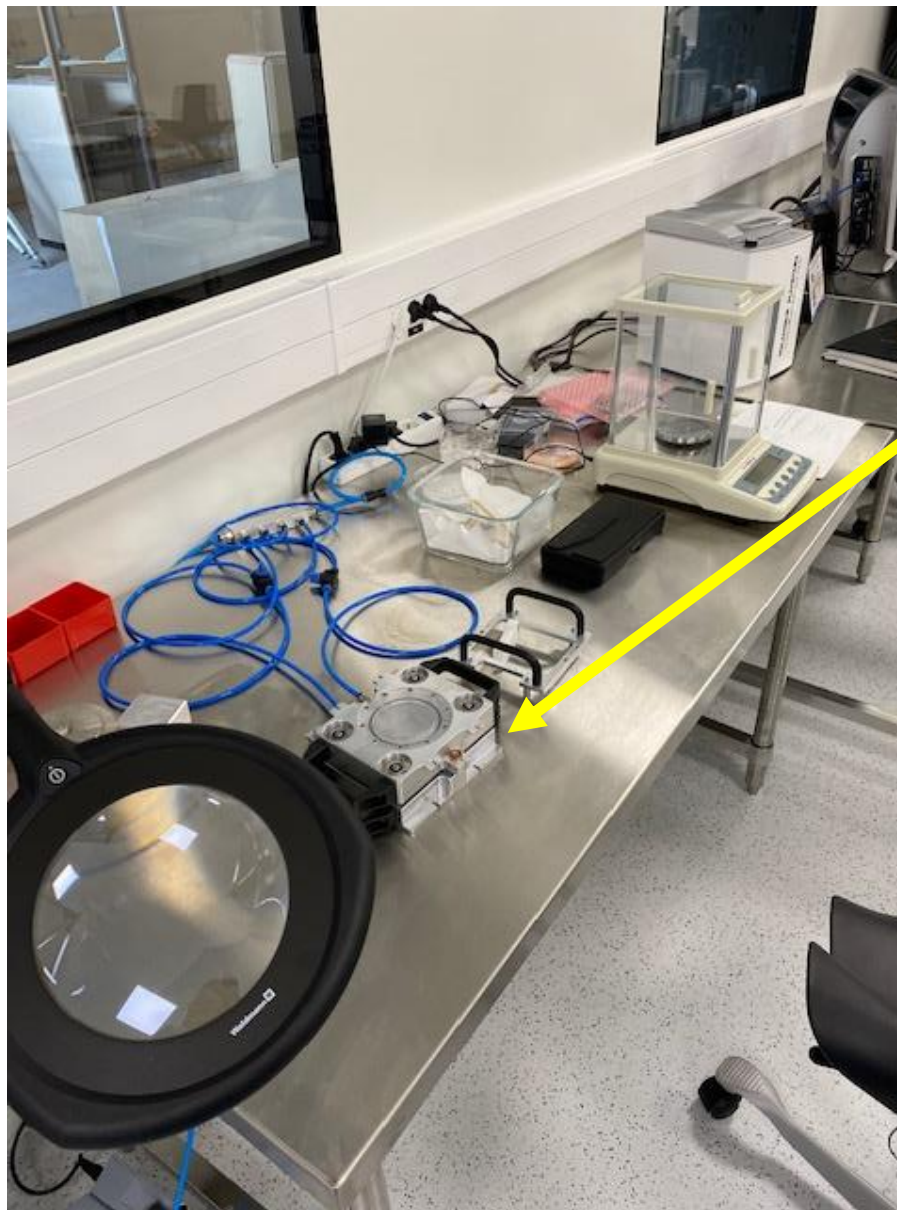




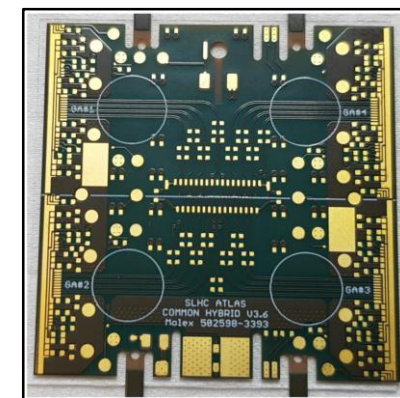
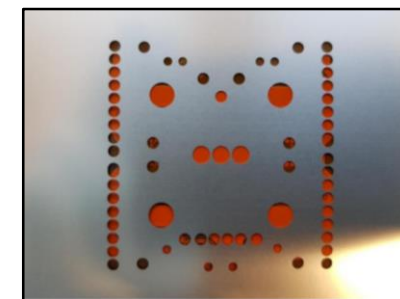
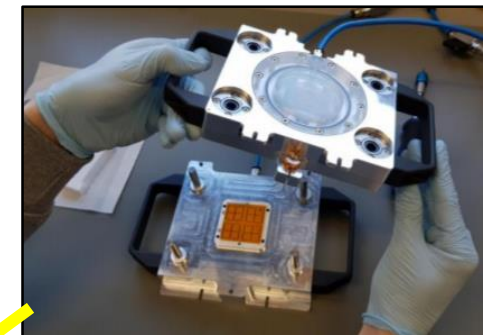
Keithely DAQ

Sensor –wafers and ASIC probing and testing

19/10/2020



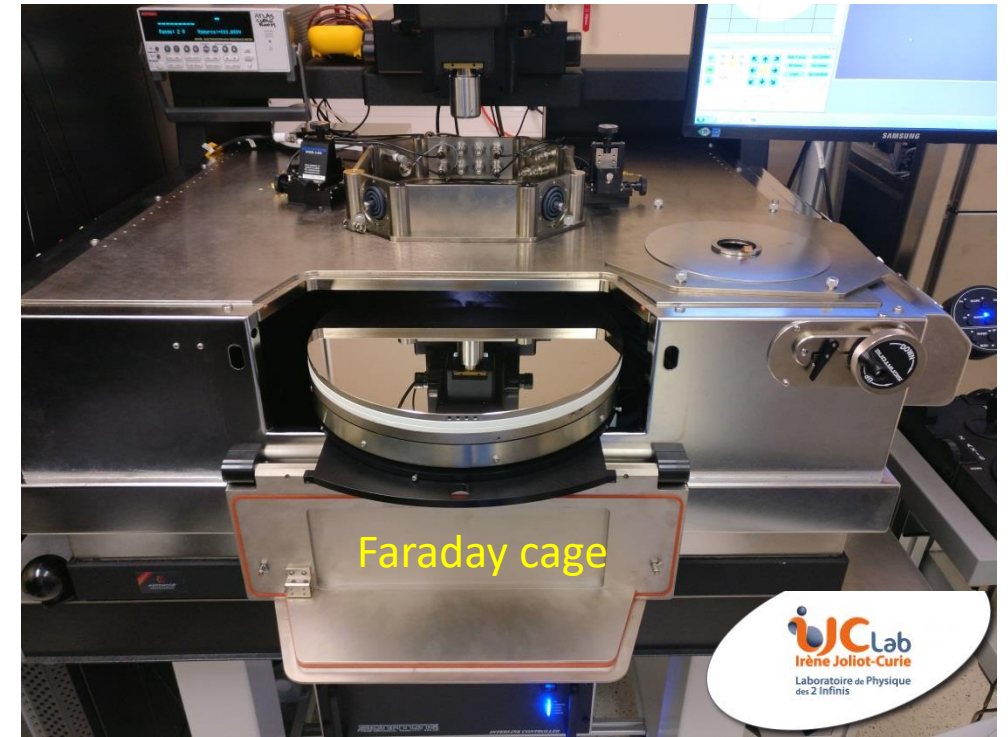
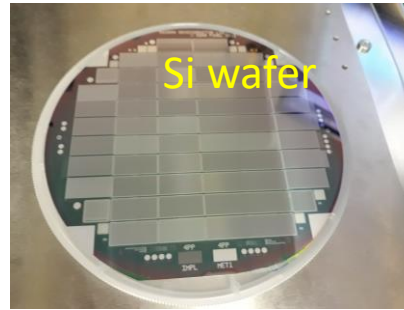
Gluing and module assembly Setup



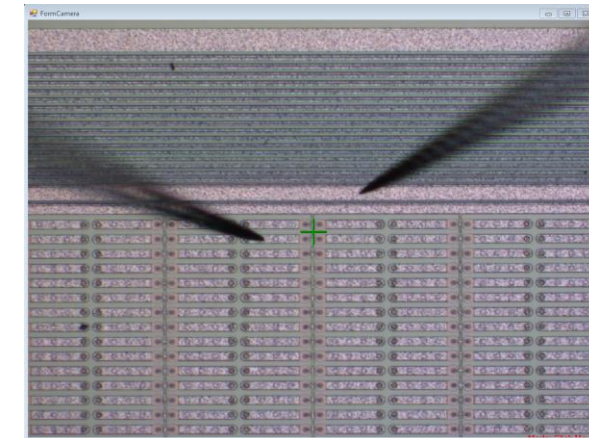
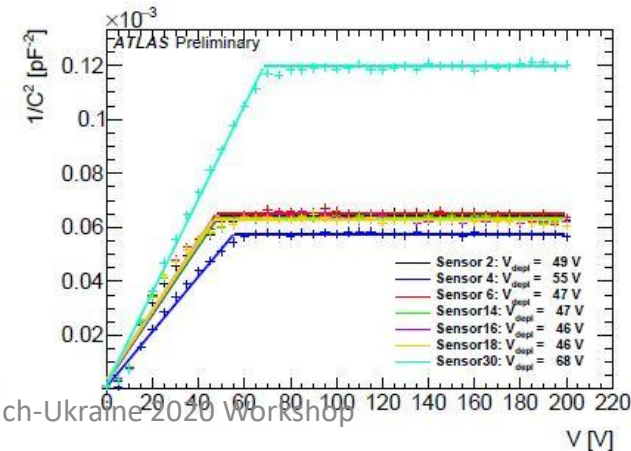
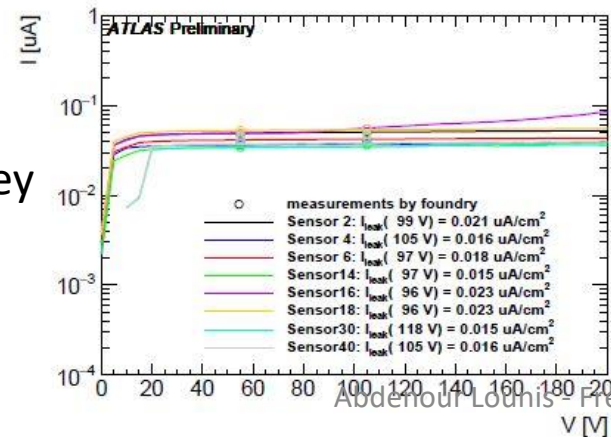
Sensor Probing as an initial step

- Powerfull probestations available (Captinnov Plateform) and LPNHE Clean room

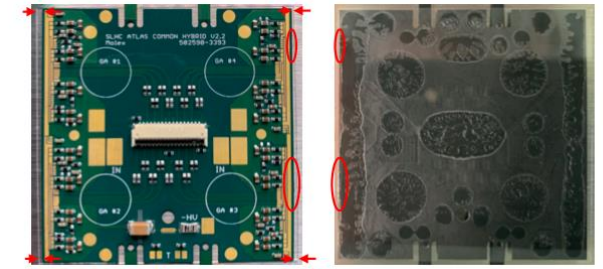
- Depletion voltage $V_{dep} < 100$ V (for $150 \mu\text{m}$ sensors) measured at 1 kHz
- Leakage current $I_{leak} < 0.75 \mu\text{A}/\text{cm}^2$ at $V_{dep} \sim 50$ V
- Variation of leakage current $\Delta I_{leak} \sim 25\%$ measured over 48 h
- Breakdown voltage : $V_{break} > V_{dep} + 70$ V



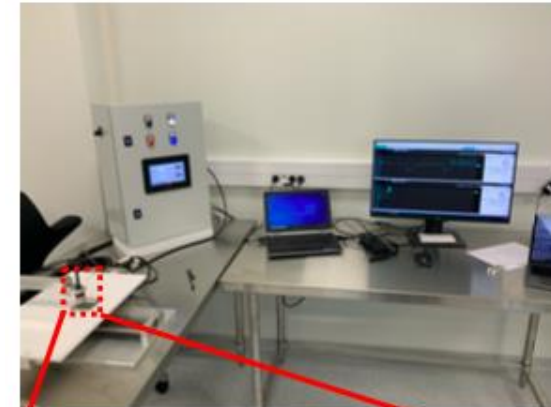
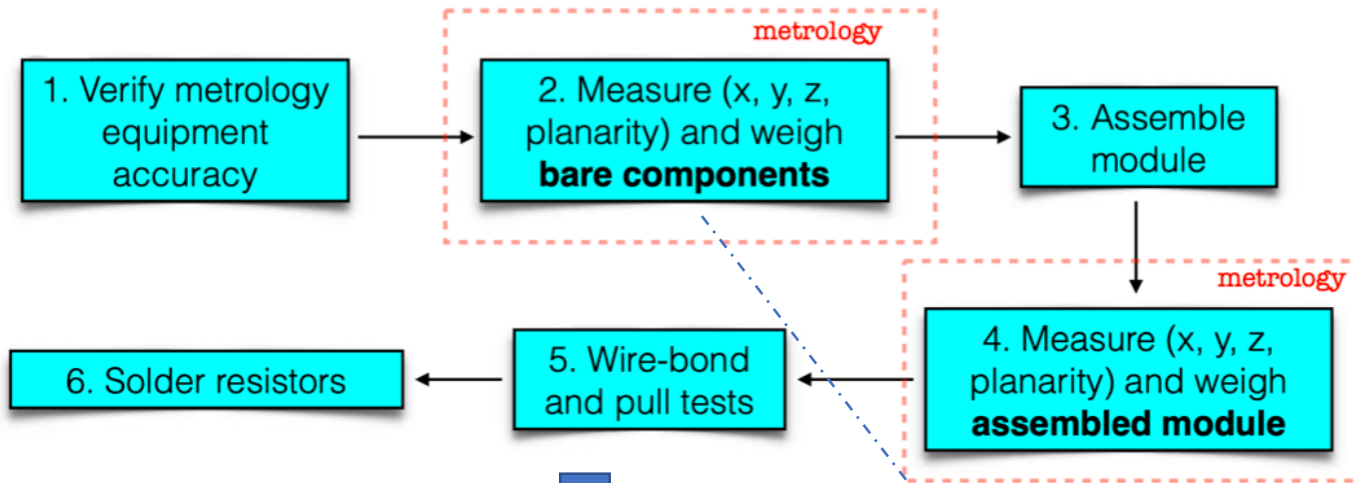
Data from Pixel Market survey



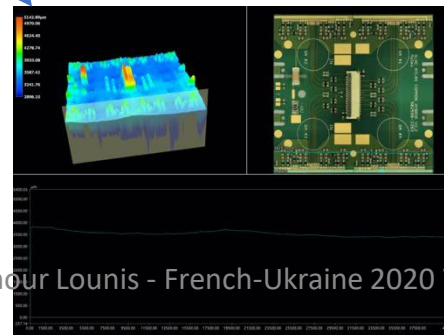
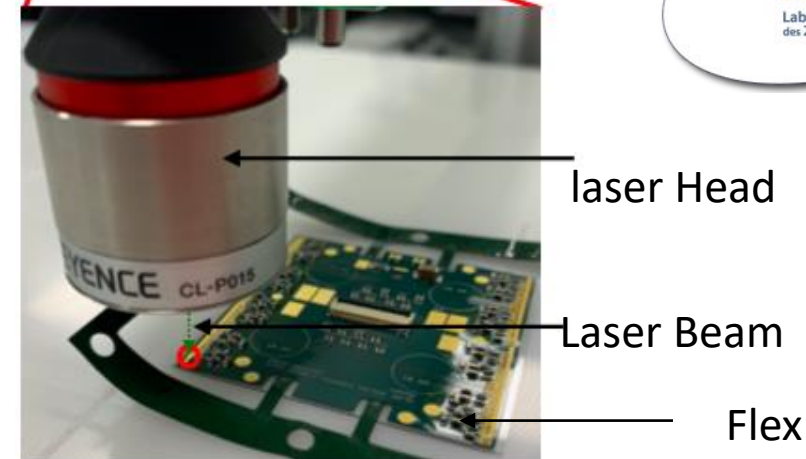
Contribution to module Assembly & QA/QC



- Project carried inside the ITK Paris-Cluster (LPNHE-CEA-IRFU, IJCLab)



Profilometer Keyence

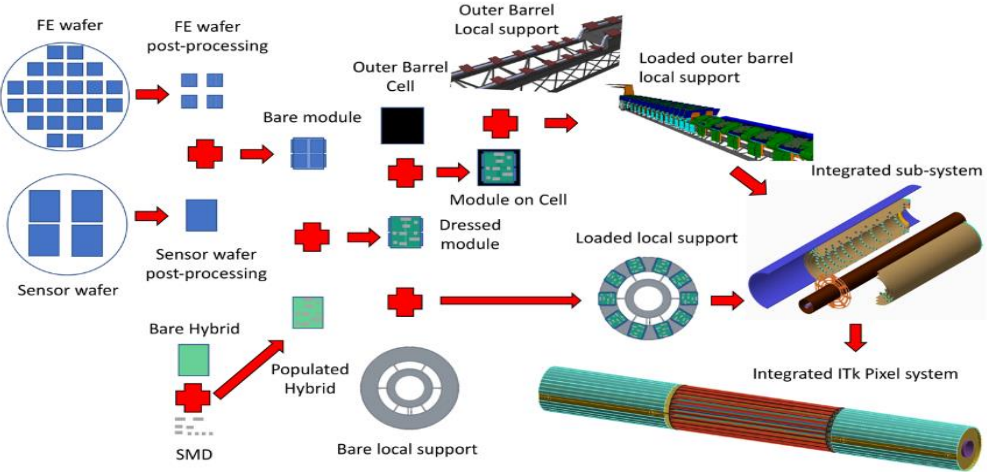


Database needed to share and retrieve the full Production

All QC measurements; QC visual inspections, sensor bow, thickness, electrical tests

Module Id - Production testing/step -

Module ID	Production Testing/step	Operator	Data
Date & Time	Cluster Name	Institute name	DB Link



❖ Photographic Documentation for module production:
 Modules should be imaged before and after each production testing step
 (# 20 pictures/module according to QC recommendations);

Infrastructure and equipment for silicon module developments and production

Important Information



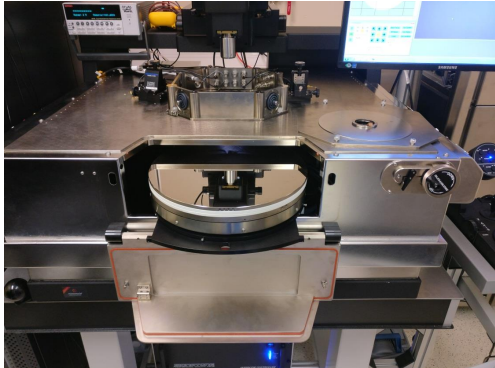
Overview of the actual infrastructure @IJC Lab



- Equipments state of the art



Tool for wafer and sensor Testing



Probe Station
Budget ~ 300 K€
(From Labex P2IO & SESAME Ile de France)
- HV Chuck*
- Compressor*

Module and Asic temp Cycling



Climate Chamber

Tool for Visual Inspection



High resolution Microscope
KEYENCE VHX-7000

Test benches for module testing and to radiation monitoring Electronics :

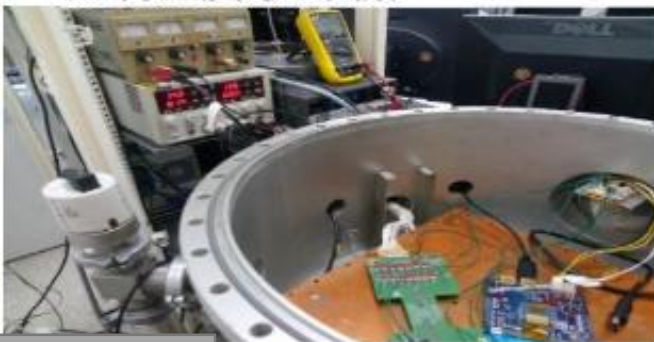
- Test benches for
 - Readout Chip ITKpixv1 (RD53) : BDAQ & YARR
 - Ring Oscillator & Systems



SETUP 1 climate chamber with RD53A SCC inside.



PC-Board Xpressk7 board for data



SETUP Open ROMIC (green chip) and RD53A (blue chip) inside the climate



Abdenour Lounis - French-Ukraine 2020 Workshop
ATLAS DAQ : BDAQ and RD53A

Ring Oscillator : Chip to monitor the Radiation dose

Designer : Maurice Cohen-Solal

- Embedded in ITKpixV1
- Performs measurement of frequency Variations as function of Temperature, Radiation and charge particle radiation exposure,
- Can Provide a feedback correction loop for ITKpixV1 working voltages

Calendar and Milestone

Schedule

Now - end of Nov. 2020: Assemble and test ~10 quad modules

❖ Including , IV/CV/It probing of bare modules will be necessary before the assembly.

• January 2021 - October 2021: Sensors pre-production

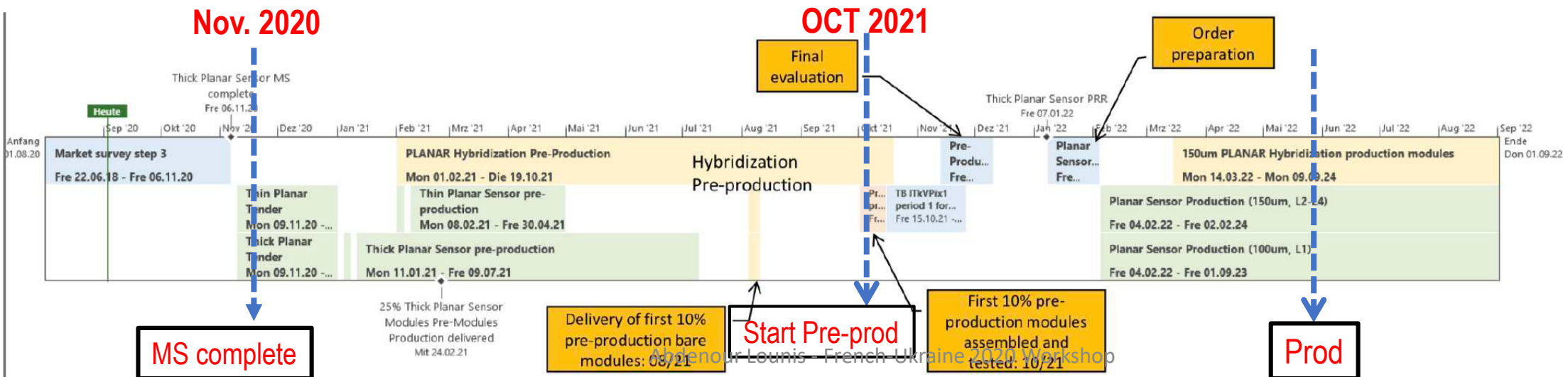
❖ Around 200 sensors allocated to Paris cluster. A good fraction of these will have to be tested using probe stations (**LPNHE + IJC**)

• October 2021 - May 2022 : Modules pre-production

❖ Paris cluster will have to assembly and qualify/test around **200 modules**

• June 2022 - ~2024-2025 : Modules Production

❖ Paris cluster will have to assembly and qualify around **2000 modules**



Conclusions

- The ATLAS French Cluster is committed in a very challenging detector construction program for HL-LHC program,
- High expertise in building complex systems of silicon Tracker will be acquired,
- A unique opportunity is given by such program to built in house a state of the art modern technological infrastructure “Si Lab”
- A beneficial valuable is gained through the close partnership within IN2P3 Labs and CEA-IRFU (exchange of expertise, open cooperation, sharing the efforts) to win this challenge.



End

